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observation

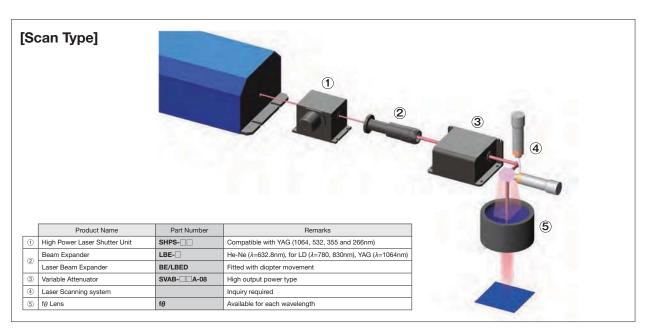
Bio-photonics

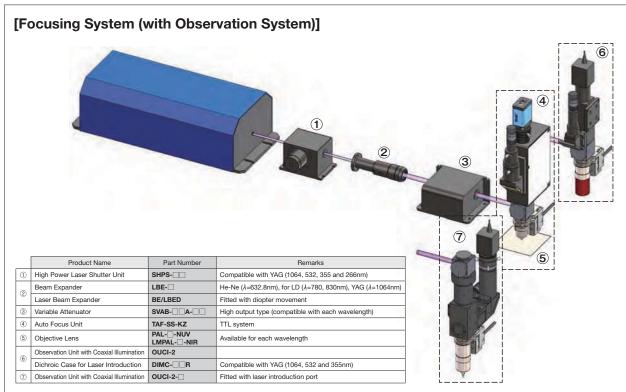
Laser Processing

Scan Optical System and Focusing Optical System

For the maskless processing, it can do direct drawing processing on the basis of the data like CAD. It is usually classified as scan optical system and focusing optical system. (There is also a hybrid scanning that combines both).

	Scan optical system	Focusing optical system
Scanning method	Galvano scan	Stage scan
Scanning speed	high	low
Scanning area	narrow	wide
Focusing method	fθ Lens	Objective Lens
Focusing spot diameter	r few 10μ – few 100μ submicron – few 10μ	
Death of focus	deep	shallow



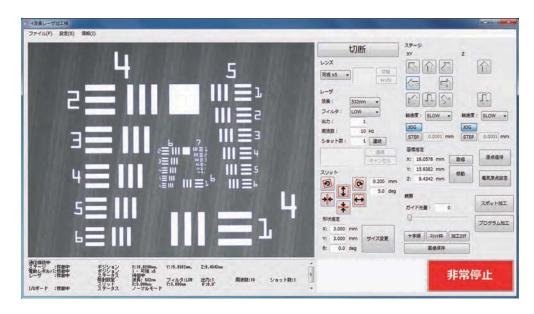


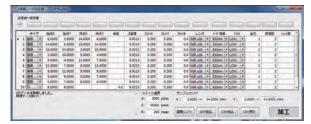
Processing Software

It is a software that can set processing pattern and area on the screen while observing the position of processing by camera.

It integrates the set of wavelength switching and irradiation condition of multiple laser, switching of the objective lens, and control of the stage.

It corresponds to drawing CAD data like DXF and to mass production line from prototype applications.





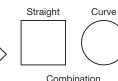
Program Operation

Stage operation by specifying coordinates

On Off operation for the laser irradiation

Easy processing by reading a CSV file

 Software Joystick Continuous movement Step movement



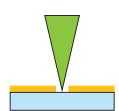
Α

ВС

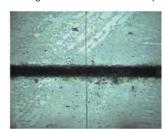
Applications

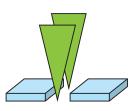
● Removing metal thin film of 10µm or less





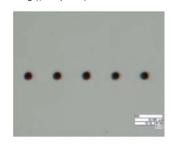
Cutting silicon wafer of about 100
µm thickness

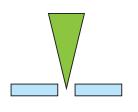




Cutting metal and ceramic of 100 − 500µm thickness, drilling (\$\phi\$100µm −)









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Shutter for High Power Laser

Safely interrupt the optical path by the highpower laser mirror and beam.



Specifications		
Part Number	SHPS-□□	
Wavelengths [nm]	266, 355, 532, 1064	
Clear aperture [mm]	φ8	
Corresponding Output	about 20W	
Laser Damage Threshold	5J/cm² (@266nm) – 28J/cm² (@1064nm)	
On-Off Speed	about 200ms	

Laser Beam Expander Unit

By lens configuration of the air gap, it is possible to correspond to high-power laser and be strict collimation adjustment in diopter correction mechanism.



Specifications		
Part Number	BE/LBED series	
Wavelengths [nm]	266, 355, 400 – 700, 1064	
Laser Damage Threshold	1.4J/cm² (@266nm) – 4J/cm² (@1064nm)	
Magnification	×2 - ×21(@400 - 700nm)	
Incident Clear Aperture[mm]	φ1.7	

Variable Attenuator

Light quantity of the high-power laser can be continuously variable by PBS and wavelength plate



Specifications		
Part Number	SVAB-□□A-OB	
Wavelengths [nm]	266, 355, 532, 1064	
Clear aperture [mm]	φ4	
Corresponding Output	20W	
Laser Damage Threshold	1.0J/cm ² (@266nm) – 5.1J/cm ² (@1064nm)	
Transmission Range	2 – 93% (@532nm)	

Auto Focus Unit

By built-in laser sensor, it enables high-speed tracking even for transparent object such as films or glasses.



Specifications		
Part Number	TAF-SS-OBL-3	
Objective Lens	2× - 100×	
Camera	C-mount CCD camera (element size 2/3" or less)	
Travel	3mm	
Trace Range (Track Range)	2x, 5x, 10x: ±1.5mm 20x : ±500µm 50x : ±250µm 100x : ±100µm	
Repeatability (Focus)	±6.0μm (5×), ±1.0μm (10×), ±0.5μm (20×, 50×, 100×)	





Surface Accuracy Guarantee Mirror

Guaranteed surface accuracy in integrated holder, ideal for built-in locking mechanism



Objective Lens

For from DUV to the near-infrared and for various processing laser



Motorized Stage

Plentiful lineup from high precision type to high rigidity long stroke.



Galvano Unit

Drawing high speed laser of high quality reducing the jitter and wobble



* it is available to assembly for each company's galvanometer. Please contact to our international sales division.

fθ Lens

Lineup in each wavelength, scanning area and focal length



Barrel Unit + Laser Introduction Block

Observation barrel of optimal coaxial epi-illumination for the positioning of the micro-machining



Base

High rigidity base series to support the stable performance



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